



**CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)**

Applicant(s): YIQIONG WANG

Docket No.

AM1562D1

Serial No.  
09/882,141Filing Date  
June 15, 2001Examiner  
Umez-EroniniGroup Art Unit  
1765

Invention: METHOD OF ETCHING HIGH ASPECT RATIO OPENINGS IN SILICON

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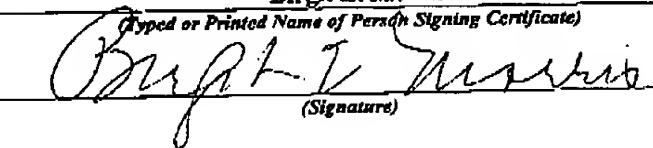
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<p>I hereby certify that this <u>Response under 37 CFR 1.115 (8pp)</u> <small>(Identify type of correspondence)</small> is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. <u>703-872-9310</u>) on <u>May 29, 2003</u> <small>(Date)</small></p> <p style="text-align: center;"><u>Birgit E. Morris</u> <small>Typed or Printed Name of Person Signing Certificate</small>  <small>(Signature)</small></p>				
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